## **CLAIMS**

- 1. A quantum well structure comprising a quantum well layer (7; 107; 207; 301) arranged between two barrier layers (9, 11; 109, 112; 209, 212; 303), characterised in that at least one of the barrier layers (9, 11; 109, 112; 209, 212; 303) comprises nanostructures (10; 110; 210; 310) which compensate or modulate a lateral homogeneity of the barrier layer (9; 109; 209; 303D), which is present without the nanostructures (10; 110; 210; 310).
- 2. A quantum well structure as set forth in claim 1 characterised in that self-organised three-dimensional structures (10; 110; 210; 310) are present as nanostructures.
- 3. A quantum well structure as set forth in claim 2 characterised in that the self-organised three-dimensional structures (10; 110; 210; 310) are made from a material which has a markedly greater lattice constant than the material of the barrier layer (9; 109; 209; 303D).
- 4. A quantum well structure as set forth in claim 2 or claim 3 characterised in that the self-organised three-dimensional nanostructures (10; 110; 210; 310) are in the form of quantum dots.
- 5. A quantum well structure as set forth in claim 2 or claim 3 characterised in that the self-organised three-dimensional nanostructures (10; 110; 210; 310) are in the form of quantum wires.
- 6. A quantum well structure as set forth in one of claims 1 through 5 characterised in that at least one of the barrier layers is in the form of an aluminum arsenide layer (9; 109; 303D) which includes indium arsenide islands (10; 110; 310) as nanostructures.

- 7. A quantum well structure as set forth in one of claims 1 through 5 characterised in that at least one of the barrier layers is in the form of an indium phosphide layer (209) which includes indium arsenide islands (210) as nanostructures.
- 8. A quantum well structure as set forth in one of the preceding claims characterised in that it comprises at least two quantum well layers (7; 107; 207; 301) which are each separated from each other at least by a respective barrier layer (9, 11; 109, 112; 209, 212; 303).
- 9. A quantum well structure as set forth in one of the preceding claims characterised in that the nanostructures (10; 110; 210; 310) are of a dimension of less than 50 nm in at least one lateral direction in which they extend.
- 10. A quantum well structure as set forth in claim 9 characterised in that the dimension is in the range of between 5 and 15 nm.
- 11. A quantum well photodetector comprising at least one quantum well structure as set forth in one of claims 1 through 10.
- 12. A quantum cascade laser comprising at least one quantum well structure as set forth in one of claims 1 through 10.